AMENDMENTS TO THE SPECIFICATION

IN THE SPECIFICATION:

Please amend the paragraph starting at page 10, line 14, as follows:

To be more specific, the GaAs layer 31, $Al_{0.15}Ga_{0.85}As$ layer 32 and $Al_{0.3}Ga_{0.7}As$ layer 33 constituting the buffer layer 30 are formed at relatively fast growth rates, and the $Al_{0.4}Ga_{0.6}As$ layer 41 that is the **first** layer of the multilayer structure 4 is formed at a slower growth rate than the growth rate of the buffer layer 3 30.